WEST

# Error:
# Your user temp file for this session on the BRS Text Search Server is near the limit.

**As a result, the results from your last L Number could not be added to your temp file. To continue searching, you must reformulate your last search query. Define a search that is as precise as possible by using limited ($n) rather than unlimited ($) truncation and by avoiding common terms (e.g., device, process, machine, etc.). You may also logoff of WEST at this time. This will clear your temp file. To avoid reaching the limit again, reevaluate and redefine your search strategy.**

Main Menu | Search Form

Go Back

WEST

Help | Logout | Interrupt

Main Menu | Search Form | Posting Counts | Show S Numbers | Edit S Numbers | Preferences

**Search Results -**

| Terms | Documents |
|---|---|
| (substrate or wafer or semiconductor) and chamber and transfer | 23575 |

**Database:** US Patents Full-Text Database; JPO Abstracts Database; EPO Abstracts Database; Derwent World Patents Index; IBM Technical Disclosure Bulletins

Refine Search: `l1 and load adj lock adj chamber` Clear

**Search History**

**Today's Date: 7/31/2000**

| DB Name | Query | Hit Count | Set Name |
|---|---|---|---|
| USPT,JPAB,EPAB | (substrate or wafer or semiconductor) and chamber and transfer | 23575 | L1 |

# Printed by EAST

**UserID:** SGravini

**Computer:** WS07447

**Date:** 07/31/2000

**Time:** 13:53

| | Type | L # | Hits | Search Text | DBs | Time Stamp |
|---|---|---|---|---|---|---|
| 1 | BRS | L1 | 837 | load adj lock adj chamber | USPAT | 2000/07/31 13:46 |
| 2 | BRS | L2 | 544 | 1 and (wafer or substrate) and (convey or trasport or transfer) | USPAT | 2000/07/31 13:47 |
| 3 | BRS | L3 | 616 | 1 and (wafer or substrate) and (convey or transport or transfer) | USPAT | 2000/07/31 13:47 |
| 4 | BRS | L4 | 210 | 3 and opening and closing and vacuum | USPAT | 2000/07/31 13:48 |

PALM INTRANET

Day : Monday
Date: 7/31/2000
Time: 12:17:44

## Inventor Name Search Result

Your Search was:

Last Name = KATO
First Name = SHIGEKAZU

Search and Display More Records.

The Display is limited to a maximum of 25 records and the Search is limited to a maximum of 1000 records.

**25 records of 26 records searched are Displayed.**

| Serial# | Patent# | Status | Date Filed | Title | Inventor Name |
|---|---|---|---|---|---|
| 07556449 | 5078851 | 115 | 07/24/1990 | LOW-TEMPERATURE PLASMA PROCESSOR | KATO , SHIGEKAZU |
| 07645420 | Not Issued | 166 | 01/24/1991 | METHOD AND APPARATUS FOR DRY ETCHING | KATO , SHIGEKAZU |
| 07724801 | 5320982 | 150 | 07/02/1991 | WAFER COOLING METHOD AND APPARATUS | KATO , SHIGEKAZU |
| 07751951 | 5314509 | 150 | 08/29/1991 | VACUUM PROCESSING APPARATUS AND OPERATING METHOD THEREFOR | KATO , SHIGEKAZU |
| 07796672 | Not Issued | 166 | 11/25/1991 | VACUUM PROCESSING SYSTEM | KATO , SHIGEKAZU |
| 07941905 | 5448470 | 150 | 09/08/1992 | MULTIPROCESSING APPARATUS | KATO , SHIGEKAZU |
| 07971484 | Not Issued | 161 | 11/04/1992 | METHOD AND APPARATUS FOR DRY ETCHING | KATO , SHIGEKAZU |
| 08096256 | 5349762 | 150 | 07/26/1993 | VACUUM PROCESSING APPARATUS AND OPERATING METHOD THEREFOR | KATO , SHIGEKAZU |
| 08131911 | 5445484 | 150 | 10/04/1993 | VACUUM PROCESSING SYSTEM | KATO , SHIGEKAZU |
| 08145181 | 5449467 | 150 | 11/03/1993 | PROCESS FOR PURIFYING WATER | KATO , SHIGEKAZU |
| 08302443 | 5457896 | 150 | 09/09/1994 | VACUUM PROCESSING APPARATUS AND OPERATING METHOD THEREFOR | KATO , SHIGEKAZU |
| 08443039 | 5553396 | 150 | 05/17/1995 | VACUUM PROCESSING APPARATUS AND OPERATING METHOD THEREFOR | KATO , SHIGEKAZU |

| | | | | | |
|---|---|---|---|---|---|
| 08457595 | Not Issued | 161 | 06/01/1995 | VACCUM PROCESSING SYSTEM | KATO , SHIGEKAZU |
| 08460600 | 5673750 | 150 | 06/02/1995 | VACUUM PROCESSING METHOD AND APPARATUS | KATO , SHIGEKAZU |
| 08461512 | Not Issued | 161 | 06/05/1995 | METHOD AND APPARATUS FOR DRY ETCHING | KATO , SHIGEKAZU |
| 08461523 | 5663884 | 150 | 06/05/1995 | MULTIPROCESSING APPARATUS | KATO , SHIGEKAZU |
| 08487643 | 5562820 | 150 | 06/07/1995 | PROCESS FOR PURIFYING WATER | KATO , SHIGEKAZU |
| 08549791 | Not Issued | 166 | 01/26/1996 | UTENSILS FOR TABLE USE AND COOKING USE | KATO , SHIGEKAZU |
| 08593870 | 5661913 | 150 | 01/30/1996 | VACUUM PROCESSING APPARATUS AND OPERATING METHOD THEREFOR | KATO , SHIGEKAZU |
| 08612465 | 5685684 | 150 | 03/07/1996 | VACUUM PROCESSING SYSTEM | KATO , SHIGEKAZU |
| 08882731 | 5784799 | 150 | 06/26/1997 | VACUUM PROCESSING APPARATUS FOR SUBSTATE WAFERS | KATO , SHIGEKAZU |
| 08940019 | 5943950 | 150 | 09/29/1997 | UTENSILS FOR TABLE USE AND COOKING USE | KATO , SHIGEKAZU |
| 09061062 | 5950330 | 150 | 04/16/1998 | VACUUM PROCESSING APPARATUS AND OPERATING METHOD THEREFOR | KATO , SHIGEKAZU |
| 09177495 | 6012235 | 150 | 10/23/1998 | VACUUM PROCESSING APPARATUS AND OPERATING METHOD THEREFOR | KATO , SHIGEKAZU |
| 09231451 | 6055740 | 150 | 01/15/1999 | VACUUM PROCESSING APPARATUS AND OPERATING METHOD THEREFOR | KATO , SHIGEKAZU |

Search and Display More Records.

The Display is limited to a maximum of 25 records and the Search is limited to a maximum of 1000 records.

**25 records of 26 records searched are Displayed.**

**Search Another: Inventor**

**Last Name** KATO **First Name** SHIGEKAZU

Search

(To Go BACK Use BACK Button on Your BROWSER Tool Bar)

Back to || PALM || ASSIGNMENT || OASIS || Home Page

PALM INTRANET

Day : Monday
Date: 7/31/2000
Time: 12:18:12

## Inventor Name Search Result

Your Search was:

Last Name = KATO
First Name = SHIGEKAZU

| Serial# | Patent# | Status | Date Filed | Title | Inventor Name |
|---|---|---|---|---|---|
| 09389461 | Not Issued | 95 | 09/03/1999 | VACUUM PROCESSING APPARATUS AND OPERATING METHOD THEREFOR | KATO , SHIGEKAZU |
| 09390681 | 6070341 | 150 | 09/07/1999 | VACUUM PROCESSING APPARATUS AND OPERATING METHOD THEREFOR | KATO , SHIGEKAZU |
| 09390684 | 6044576 | 150 | 09/07/1999 | VACUUM PROCESSING APPARATUS AND OPERATING METHOD THEREFOR | KATO , SHIGEKAZU |
| 09461432 | Not Issued | 93 | 12/16/1999 | VACUUM PROCESSING APPARATUS AND OPERATING METHOD THEREFOR | KATO , SHIGEKAZU |
| 09461433 | Not Issued | 95 | 12/16/1999 | VACUUM PROCESSING APPARATUS AND OPERATING METHOD THEREFOR | KATO , SHIGEKAZU |
| 09552572 | Not Issued | 30 | 04/19/2000 | VACUUM PROCESSING APPARATUS AND OPERATING METHOD THEREFOR | KATO , SHIGEKAZU |
| 29099071 | Not Issued | 41 | 01/12/1999 | VACUUM PROCESSING EQUIPMENT CONFIGURATION | KATO , SHIGEKAZU |
| 29099072 | Not Issued | 41 | 01/12/1999 | VACUUM PROCESSING SYSTEM CONFIGURATION | KATO , SHIGEKAZU |

Search and Display More Records.

The Display is limited to a maximum of 25 records and the Search is limited to a maximum of 1000 records.

**8 records of 1000 records searched are Displayed.**

**Search Another: Inventor**

| Last Name | First Name |
| --- | --- |
| KATO | SHIGEKAZU |

Search

(To Go BACK Use BACK Button on Your BROWSER Tool Bar)

Back to || PALM || ASSIGNMENT || OASIS || Home Page

PALM INTRANET

Day : Monday
Date: 7/31/2000
Time: 12:19:30

## Inventor Name Search Result

Your Search was:

Last Name = NISHIHATA
First Name = KOUJI

Search and Display More Records.

The Display is limited to a maximum of 25 records and the Search is limited to a maximum of 1000 records.

**25 records of 26 records searched are Displayed.**

| Serial# | Patent# | Status | Date Filed | Title | Inventor Name |
|---|---|---|---|---|---|
| 06493512 | 4527698 | 150 | 05/11/1983 | METHOD OF AND APPARATUS FOR SUPPORTING ROPE OF CRANE HAVING | NISHIHATA , KOUJI |
| 07556449 | 5078851 | 115 | 07/24/1990 | LOW-TEMPERATURE PLASMA PROCESSOR | NISHIHATA , KOUJI |
| 07645420 | Not Issued | 166 | 01/24/1991 | METHOD AND APPARATUS FOR DRY ETCHING | NISHIHATA , KOUJI |
| 07724801 | 5320982 | 150 | 07/02/1991 | WAFER COOLING METHOD AND APPARATUS | NISHIHATA , KOUJI |
| 07751951 | 5314509 | 150 | 08/29/1991 | VACUUM PROCESSING APPARATUS AND OPERATING METHOD THEREFOR | NISHIHATA , KOUJI |
| 07796672 | Not Issued | 166 | 11/25/1991 | VACUUM PROCESSING SYSTEM | NISHIHATA , KOUJI |
| 07941905 | 5448470 | 150 | 09/08/1992 | MULTIPROCESSING APPARATUS | NISHIHATA , KOUJI |
| 07971484 | Not Issued | 161 | 11/04/1992 | METHOD AND APPARATUS FOR DRY ETCHING | NISHIHATA , KOUJI |
| 08096256 | 5349762 | 150 | 07/26/1993 | VACUUM PROCESSING APPARATUS AND OPERATING METHOD THEREFOR | NISHIHATA , KOUJI |
| 08131911 | 5445484 | 150 | 10/04/1993 | VACUUM PROCESSING SYSTEM | NISHIHATA , KOUJI |
| 08302443 | 5457896 | 150 | 09/09/1994 | VACUUM PROCESSING APPARATUS AND OPERATING METHOD THEREFOR | NISHIHATA , KOUJI |
| 08443039 | 5553396 | 150 | 05/17/1995 | VACUUM PROCESSING APPARATUS AND OPERATING METHOD THEREFOR | NISHIHATA , KOUJI |

| | | | | | |
|---|---|---|---|---|---|
| 08457595 | Not Issued | 161 | 06/01/1995 | VACCUM PROCESSING SYSTEM | NISHIHATA , KOUJI |
| 08460600 | 5673750 | 150 | 06/02/1995 | VACUUM PROCESSING METHOD AND APPARATUS | NISHIHATA , KOUJI |
| 08461512 | Not Issued | 161 | 06/05/1995 | METHOD AND APPARATUS FOR DRY ETCHING | NISHIHATA , KOUJI |
| 08461523 | 5663884 | 150 | 06/05/1995 | MULTIPROCESSING APPARATUS | NISHIHATA , KOUJI |
| 08593870 | 5661913 | 150 | 01/30/1996 | VACUUM PROCESSING APPARATUS AND OPERATING METHOD THEREFOR | NISHIHATA , KOUJI |
| 08612465 | 5685684 | 150 | 03/07/1996 | VACUUM PROCESSING SYSTEM | NISHIHATA , KOUJI |
| 08882731 | 5784799 | 150 | 06/26/1997 | VACUUM PROCESSING APPARATUS FOR SUBSTATE WAFERS | NISHIHATA , KOUJI |
| 08925190 | 6069096 | 150 | 09/08/1997 | OPERATING METHOD OF VACUUM PROCESSING SYSTEM AND VACUUM PROCESSING | NISHIHATA , KOUJI |
| 09061062 | 5950330 | 150 | 04/16/1998 | VACUUM PROCESSING APPARATUS AND OPERATING METHOD THEREFOR | NISHIHATA , KOUJI |
| 09177495 | 6012235 | 150 | 10/23/1998 | VACUUM PROCESSING APPARATUS AND OPERATING METHOD THEREFOR | NISHIHATA , KOUJI |
| 09231451 | 6055740 | 150 | 01/15/1999 | VACUUM PROCESSING APPARATUS AND OPERATING METHOD THEREFOR | NISHIHATA , KOUJI |
| 09389461 | Not Issued | 95 | 09/03/1999 | VACUUM PROCESSING APPARATUS AND OPERATING METHOD THEREFOR | NISHIHATA , KOUJI |
| 09390681 | 6070341 | 150 | 09/07/1999 | VACUUM PROCESSING APPARATUS AND OPERATING METHOD THEREFOR | NISHIHATA , KOUJI |

Search and Display More Records.

The Display is limited to a maximum of 25 records and the Search is limited to a maximum of 1000 records.

**25 records of 26 records searched are Displayed.**

**Search Another: Inventor**

**Last Name** NISHIHATA **First Name** KOUJI

Search

(To Go BACK Use BACK Button on Your BROWSER Tool Bar)

Back to || PALM || ASSIGNMENT || OASIS || Home Page

PALM INTRANET

Day : Monday
Date: 7/31/2000
Time: 12:19:37

## Inventor Name Search Result

Your Search was:

Last Name = NISHIHATA
First Name = KOUJI

| Serial# | Patent# | Status | Date Filed | Title | Inventor Name |
|---|---|---|---|---|---|
| 09390684 | 6044576 | 150 | 09/07/1999 | VACUUM PROCESSING APPARATUS AND OPERATING METHOD THEREFOR | NISHIHATA , KOUJI |
| 09452174 | Not Issued | 30 | 12/01/1999 | ETCHING END POINT JUDGING METHOD, ETCHING END POINT JUDGING DEVICE, | NISHIHATA , KOUJI |
| 09461432 | Not Issued | 93 | 12/16/1999 | VACUUM PROCESSING APPARATUS AND OPERATING METHOD THEREFOR | NISHIHATA , KOUJI |
| 09461433 | Not Issued | 95 | 12/16/1999 | VACUUM PROCESSING APPARATUS AND OPERATING METHOD THEREFOR | NISHIHATA , KOUJI |
| 09526206 | Not Issued | 30 | 03/15/2000 | VACUUM PROCESS APPARATUS AND METHOD OF OPERATING THE SAME | NISHIHATA , KOUJI |
| 09535753 | Not Issued | 22 | 03/27/2000 | OPERATING METHOD OF VACUUM PROCESSING SYSTEM AND VACUUM PROCESSING SYS | NISHIHATA , KOUJI |
| 09552572 | Not Issued | 30 | 04/19/2000 | VACUUM PROCESSING APPARATUS AND OPERATING METHOD THEREFOR | NISHIHATA , KOUJI |
| 29099071 | Not Issued | 41 | 01/12/1999 | VACUUM PROCESSING EQUIPMENT CONFIGURATION | NISHIHATA , KOUJI |
| 29099072 | Not Issued | 41 | 01/12/1999 | VACUUM PROCESSING SYSTEM CONFIGURATION | NISHIHATA , KOUJI |

Inventor Search Completed: No more records to search.

**Search Another: Inventor**

| Last Name | First Name |
| --- | --- |
| NISHIHATA | KOUJI |

Search

(To Go BACK Use BACK Button on Your BROWSER Tool Bar)

Back to || PALM || ASSIGNMENT || OASIS || Home Page

PALM INTRANET

Day : Monday
Date: 7/31/2000
Time: 12:19:50

## Inventor Name Search Result

Your Search was:

Last Name = TSUBONE
First Name = TSUNEHIKO

Search and Display More Records.

The Display is limited to a maximum of 25 records and the Search is limited to a maximum of 1000 records.

**25 records of 26 records searched are Displayed.**

| Serial# | Patent# | Status | Date Filed | Title | Inventor Name |
|---|---|---|---|---|---|
| 06674772 | Not Issued | 168 | 11/26/1984 | VACUUM PROCESSING UNIT AND APPARATUS | TSUBONE , TSUNEHIKO |
| 06675863 | 4565601 | 115 | 11/28/1984 | METHOD AND APPARATUS FOR CONTROLLING SAMPLE TEMPERATURE | TSUBONE , TSUNEHIKO |
| 06904202 | 4824309 | 115 | 09/08/1986 | VACUUM PROCESSING UNIT AND APPARATUS | TSUBONE , TSUNEHIKO |
| 07258468 | 4911812 | 150 | 10/17/1988 | PLASMA TREATING METHOD AND APPARATUS THEREFOR | TSUBONE , TSUNEHIKO |
| 07338038 | 5085750 | 115 | 04/14/1989 | PLASMA TREATING METHOD AND APPARATUS THEREFOR | TSUBONE , TSUNEHIKO |
| 07556449 | 5078851 | 115 | 07/24/1990 | LOW-TEMPERATURE PLASMA PROCESSOR | TSUBONE , TSUNEHIKO |
| 07645420 | Not Issued | 166 | 01/24/1991 | METHOD AND APPARATUS FOR DRY ETCHING | TSUBONE , TSUNEHIKO |
| 07724801 | 5320982 | 150 | 07/02/1991 | WAFER COOLING METHOD AND APPARATUS | TSUBONE , TSUNEHIKO |
| 07751951 | 5314509 | 150 | 08/29/1991 | VACUUM PROCESSING APPARATUS AND OPERATING METHOD THEREFOR | TSUBONE , TSUNEHIKO |
| 07796672 | Not Issued | 166 | 11/25/1991 | VACUUM PROCESSING SYSTEM | TSUBONE , TSUNEHIKO |
| 07941905 | 5448470 | 150 | 09/08/1992 | MULTIPROCESSING APPARATUS | TSUBONE , TSUNEHIKO |
| 07971484 | Not Issued | 161 | 11/04/1992 | METHOD AND APPARATUS FOR DRY ETCHING | TSUBONE , TSUNEHIKO |
| 08096256 | 5349762 | 150 | 07/26/1993 | VACUUM PROCESSING APPARATUS AND OPERATING | TSUBONE , TSUNEHIKO |

| | | | | | |
|---|---|---|---|---|---|
| | | | | METHOD THEREFOR | |
| 08131911 | 5445484 | 150 | 10/04/1993 | VACUUM PROCESSING SYSTEM | TSUBONE , TSUNEHIKO |
| 08302443 | 5457896 | 150 | 09/09/1994 | VACUUM PROCESSING APPARATUS AND OPERATING METHOD THEREFOR | TSUBONE , TSUNEHIKO |
| 08307238 | 5792304 | 150 | 09/16/1994 | METHOD OF HOLDING SUBSTRATE AND SUBSTRATE HOLDING SYSTEM | TSUBONE , TSUNEHIKO |
| 08443039 | 5553396 | 150 | 05/17/1995 | VACUUM PROCESSING APPARATUS AND OPERATING METHOD THEREFOR | TSUBONE , TSUNEHIKO |
| 08457595 | Not Issued | 161 | 06/01/1995 | VACCUM PROCESSING SYSTEM | TSUBONE , TSUNEHIKO |
| 08460600 | 5673750 | 150 | 06/02/1995 | VACUUM PROCESSING METHOD AND APPARATUS | TSUBONE , TSUNEHIKO |
| 08461512 | Not Issued | 161 | 06/05/1995 | METHOD AND APPARATUS FOR DRY ETCHING | TSUBONE , TSUNEHIKO |
| 08461523 | 5663884 | 150 | 06/05/1995 | MULTIPROCESSING APPARATUS | TSUBONE , TSUNEHIKO |
| 08593870 | 5661913 | 150 | 01/30/1996 | VACUUM PROCESSING APPARATUS AND OPERATING METHOD THEREFOR | TSUBONE , TSUNEHIKO |
| 08612465 | 5685684 | 150 | 03/07/1996 | VACUUM PROCESSING SYSTEM | TSUBONE , TSUNEHIKO |
| 08670180 | 6048434 | 150 | 06/20/1996 | A SUBSTRATE HOLDING SYSTEM INCLUDING AN ELECTROSTATIC CHUCK | TSUBONE , TSUNEHIKO |
| 08882731 | 5784799 | 150 | 06/26/1997 | VACUUM PROCESSING APPARATUS FOR SUBSTATE WAFERS | TSUBONE , TSUNEHIKO |

Search and Display More Records.

The Display is limited to a maximum of 25 records and the Search is limited to a maximum of 1000 records.

**25 records of 26 records searched are Displayed.**

**Search Another: Inventor**

**Last Name** TSUBONE **First Name** TSUNEHIKO

Search

(To Go BACK Use BACK Button on Your BROWSER Tool Bar)

Back to || PALM || ASSIGNMENT || OASIS || Home Page

PALM INTRANET

Day : Monday
Date: 7/31/2000
Time: 12:20:11

## Inventor Name Search Result

Your Search was:

Last Name = TSUBONE
First Name = TSUNEHIKO

| Serial# | Patent# | Status | Date Filed | Title | Inventor Name |
|---|---|---|---|---|---|
| 08979949 | Not Issued | 71 | 11/26/1997 | PLASMA PROCESSING APPARATUS AND METHOD | TSUBONE , TSUNEHIKO |
| 09050417 | 5906684 | 150 | 03/31/1998 | METHOD OF HOLDING SUBSTRATE AND SUBSTRATE HOLDING SYSTEM | TSUBONE , TSUNEHIKO |
| 09061062 | 5950330 | 150 | 04/16/1998 | VACUUM PROCESSING APPARATUS AND OPERATING METHOD THEREFOR | TSUBONE , TSUNEHIKO |
| 09108835 | Not Issued | 41 | 07/02/1998 | METHOD OF HOLDING SUBSTRATE AND SUBSTRATE HOLDING SYSTEM | TSUBONE , TSUNEHIKO |
| 09109033 | 5985035 | 150 | 07/02/1998 | METHOD OF HOLDING SUBSTRATE AND SUBSTRATE HOLDING SYSTEM | TSUBONE , TSUNEHIKO |
| 09109178 | Not Issued | 41 | 07/02/1998 | METHOD OF HOLDING SUBSTRATE AND SUBSTRATE HOLDING SYSTEM | TSUBONE , TSUNEHIKO |
| 09177495 | 6012235 | 150 | 10/23/1998 | VACUUM PROCESSING APPARATUS AND OPERATING METHOD THEREFOR | TSUBONE , TSUNEHIKO |
| 09231451 | 6055740 | 150 | 01/15/1999 | VACUUM PROCESSING APPARATUS AND OPERATING METHOD THEREFOR | TSUBONE , TSUNEHIKO |
| 09389461 | Not Issued | 95 | 09/03/1999 | VACUUM PROCESSING APPARATUS AND OPERATING METHOD THEREFOR | TSUBONE , TSUNEHIKO |

| | | | | | |
|---|---|---|---|---|---|
| 09390681 | 6070341 | 150 | 09/07/1999 | VACUUM PROCESSING APPARATUS AND OPERATING METHOD THEREFOR | TSUBONE , TSUNEHIKO |
| 09390684 | 6044576 | 150 | 09/07/1999 | VACUUM PROCESSING APPARATUS AND OPERATING METHOD THEREFOR | TSUBONE , TSUNEHIKO |
| 09461432 | Not Issued | 93 | 12/16/1999 | VACUUM PROCESSING APPARATUS AND OPERATING METHOD THEREFOR | TSUBONE , TSUNEHIKO |
| 09461433 | Not Issued | 95 | 12/16/1999 | VACUUM PROCESSING APPARATUS AND OPERATING METHOD THEREFOR | TSUBONE , TSUNEHIKO |
| 09478992 | Not Issued | 41 | 01/07/2000 | METHOD OF HOLDING SUBSTRATE AND SUBSTRATE HOLDING SYSTEM | TSUBONE , TSUNEHIKO |
| 09520831 | Not Issued | 30 | 03/08/2000 | PLASMA PROCESSING APPARATUS AND METHOD | TSUBONE , TSUNEHIKO |
| 09552572 | Not Issued | 30 | 04/19/2000 | VACUUM PROCESSING APPARATUS AND OPERATING METHOD THEREFOR | TSUBONE , TSUNEHIKO |
| 29099071 | Not Issued | 41 | 01/12/1999 | VACUUM PROCESSING EQUIPMENT CONFIGURATION | TSUBONE , TSUNEHIKO |
| 29099072 | Not Issued | 41 | 01/12/1999 | VACUUM PROCESSING SYSTEM CONFIGURATION | TSUBONE , TSUNEHIKO |

Inventor Search Completed: No more records to search.

**Search Another: Inventor**

**Last Name** TSUBONE **First Name** TSUNEHIKO

Search

(To Go BACK Use BACK Button on Your BROWSER Tool Bar)

Back to || PALM || ASSIGNMENT || OASIS || Home Page

PALM INTRANET

Day : Monday
Date: 7/31/2000
Time: 12:21:43

## Inventor Name Search Result

Your Search was:

Last Name = ITOU
First Name = ATSUSHI

Search and Display More Records.

The Display is limited to a maximum of 25 records and the Search is limited to a maximum of 1000 records.

**25 records of 26 records searched are Displayed.**

| Serial# | Patent# | Status | Date Filed | Title | Inventor Name |
|---|---|---|---|---|---|
| 07556449 | 5078851 | 115 | 07/24/1990 | LOW-TEMPERATURE PLASMA PROCESSOR | ITOU , ATSUSHI |
| 07615554 | 5105173 | 115 | 11/19/1990 | BAND-PASS FILTER USING MICROSTRIP LINES AND FILTER CHARACTERISTIC | ITOU , ATSUSHI |
| 07645420 | Not Issued | 166 | 01/24/1991 | METHOD AND APPARATUS FOR DRY ETCHING | ITOU , ATSUSHI |
| 07724801 | 5320982 | 150 | 07/02/1991 | WAFER COOLING METHOD AND APPARATUS | ITOU , ATSUSHI |
| 07751951 | 5314509 | 150 | 08/29/1991 | VACUUM PROCESSING APPARATUS AND OPERATING METHOD THEREFOR | ITOU , ATSUSHI |
| 07796672 | Not Issued | 166 | 11/25/1991 | VACUUM PROCESSING SYSTEM | ITOU , ATSUSHI |
| 07941905 | 5448470 | 150 | 09/08/1992 | MULTIPROCESSING APPARATUS | ITOU , ATSUSHI |
| 07971484 | Not Issued | 161 | 11/04/1992 | METHOD AND APPARATUS FOR DRY ETCHING | ITOU , ATSUSHI |
| 08096256 | 5349762 | 150 | 07/26/1993 | VACUUM PROCESSING APPARATUS AND OPERATING METHOD THEREFOR | ITOU , ATSUSHI |
| 08131911 | 5445484 | 150 | 10/04/1993 | VACUUM PROCESSING SYSTEM | ITOU , ATSUSHI |
| 08302443 | 5457896 | 150 | 09/09/1994 | VACUUM PROCESSING APPARATUS AND OPERATING METHOD THEREFOR | ITOU , ATSUSHI |
| 08443039 | 5553396 | 150 | 05/17/1995 | VACUUM PROCESSING APPARATUS AND OPERATING METHOD THEREFOR | ITOU , ATSUSHI |

| | | | | | |
|---|---|---|---|---|---|
| 08457595 | Not Issued | 161 | 06/01/1995 | VACCUM PROCESSING SYSTEM | ITOU , ATSUSHI |
| 08460600 | 5673750 | 150 | 06/02/1995 | VACUUM PROCESSING METHOD AND APPARATUS | ITOU , ATSUSHI |
| 08461512 | Not Issued | 161 | 06/05/1995 | METHOD AND APPARATUS FOR DRY ETCHING | ITOU , ATSUSHI |
| 08461523 | 5663884 | 150 | 06/05/1995 | MULTIPROCESSING APPARATUS | ITOU , ATSUSHI |
| 08593870 | 5661913 | 150 | 01/30/1996 | VACUUM PROCESSING APPARATUS AND OPERATING METHOD THEREFOR | ITOU , ATSUSHI |
| 08612465 | 5685684 | 150 | 03/07/1996 | VACUUM PROCESSING SYSTEM | ITOU , ATSUSHI |
| 08882731 | 5784799 | 150 | 06/26/1997 | VACUUM PROCESSING APPARATUS FOR SUBSTATE WAFERS | ITOU , ATSUSHI |
| 09061062 | 5950330 | 150 | 04/16/1998 | VACUUM PROCESSING APPARATUS AND OPERATING METHOD THEREFOR | ITOU , ATSUSHI |
| 09158282 | 6028147 | 150 | 09/22/1998 | BLOCK COPOLYMER, PROCESS FOR PRODUCING THE SAME AND RESIN COMPOSITION | ITOU , ATSUSHI |
| 09177495 | 6012235 | 150 | 10/23/1998 | VACUUM PROCESSING APPARATUS AND OPERATING METHOD THEREFOR | ITOU , ATSUSHI |
| 09231451 | 6055740 | 150 | 01/15/1999 | VACUUM PROCESSING APPARATUS AND OPERATING METHOD THEREFOR | ITOU , ATSUSHI |
| 09389461 | Not Issued | 95 | 09/03/1999 | VACUUM PROCESSING APPARATUS AND OPERATING METHOD THEREFOR | ITOU , ATSUSHI |
| 09390681 | 6070341 | 150 | 09/07/1999 | VACUUM PROCESSING APPARATUS AND OPERATING METHOD THEREFOR | ITOU , ATSUSHI |

Search and Display More Records.

The Display is limited to a maximum of 25 records and the Search is limited to a maximum of 1000 records.

**25 records of 26 records searched are Displayed.**

**Search Another: Inventor**

**Last Name** ITOU **First Name** ATSUSHI

Search

(To Go BACK Use BACK Button on Your BROWSER Tool Bar)

Back to || PALM || ASSIGNMENT || OASIS || Home Page

PALM INTRANET

Day : Monday
Date: 7/31/2000
Time: 12:21:57

## Inventor Name Search Result

Your Search was:

Last Name = ITOU
First Name = ATSUSHI

| Serial# | Patent# | Status | Date Filed | Title | Inventor Name |
|---|---|---|---|---|---|
| 09390684 | 6044576 | 150 | 09/07/1999 | VACUUM PROCESSING APPARATUS AND OPERATING METHOD THEREFOR | ITOU , ATSUSHI |
| 09461432 | Not Issued | 93 | 12/16/1999 | VACUUM PROCESSING APPARATUS AND OPERATING METHOD THEREFOR | ITOU , ATSUSHI |
| 09461433 | Not Issued | 95 | 12/16/1999 | VACUUM PROCESSING APPARATUS AND OPERATING METHOD THEREFOR | ITOU , ATSUSHI |
| 09552572 | Not Issued | 30 | 04/19/2000 | VACUUM PROCESSING APPARATUS AND OPERATING METHOD THEREFOR | ITOU , ATSUSHI |
| 29099071 | Not Issued | 41 | 01/12/1999 | VACUUM PROCESSING EQUIPMENT CONFIGURATION | ITOU , ATSUSHI |
| 29099072 | Not Issued | 41 | 01/12/1999 | VACUUM PROCESSING SYSTEM CONFIGURATION | ITOU , ATSUSHI |

Inventor Search Completed: No more records to search.

**Search Another: Inventor**

**Last Name** ITOU **First Name** ATSUSHI

Search

(To Go BACK Use BACK Button on Your BROWSER Tool Bar)

Back to || PALM || ASSIGNMENT || OASIS || Home Page